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Amendment to the Claims

This listing of claims will replace all prior versions, and listings, of claims in the

application.

Listing of Claims.

Claims 1-26 (cancelled)

27. (new) A method for use with differing electro-mechanical infrastructures, to

minimize the effects on the performance of a first RF radiating/receiving element located

within one such infrastructure due to its interactions with said such infrastructure,

comprising the step of placing a first metallic structure physically closer to said first RF

radiating/receiving element than said infrastructure is.

28. (new) The method of claim 27, wherein said placed first metallic structure is RF

radiating/receiving material and said first RF radiating/receiving element is a slot formed

from said material, thereby forming a first slot antenna.

29. (new) The method of claim 28, comprising the additional step of placing a

second metallic structure physically closer to a second RF radiating/receiving element

than said infrastructure is, wherein said placed second metallic structure is RF

radiating/receiving material and said second RF radiating/receiving element is a slot

formed from said material, thereby forming a second slot antenna.

30. (new) The method of claim 29, wherein said placing of first and second metallic

structures is performed to effect cooperative RF performance of said first and second

antennas.

31. (new) The method of claim 30, wherein the cooperative performance is achieved

by locating said first and second antennas so that the dominant null of the RF

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radiating/receiving element of one antenna is mitigated by the RF radiating/receiving element of the other antenna.

- 32. (new) The method of claim 31, wherein the infrastructure is that of a conventional resource-measuring meter.
- 33. (new) The method of claim 32, wherein the infrastructure is that of a conventional resource-measuring meter.
- 34. (new) The method of claim 27, wherein said placing of first metallic structure includes (a) the supporting of said first metallic structure with a supporter having dielectric properties that do not adversely affect the performance of said first RF radiating/receiving element and (b) the shaping of said supporter to maximize the amount of surface space for supporting said first metallic structure.
- 35. (new) A method of retrofitting a conventional resource-measuring unit having a metallic infrastructure of conventional prongs, brackets, rivets and metallic elements, with RF telemetry functionality, comprising the steps of:
- (a) providing RF functionality with a first RF radiating/receiving element within the infrastructure; and
- (b) placing a first metallic structure physically closer to said first RF radiating/receiving element than the infrastructure is.
- 36. (new) The method of claim 35, wherein said placed first metallic structure is radiating/receiving material and said first RF radiating/receiving element is a slot formed from said material, thereby forming a first slot antenna.
- 37. (new) The method of claim 36, further comprising the step of:

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- (c) placing a second metallic structure physically closer to said second RF radiating/receiving element than the infrastructure is.
- 38. (new) The method of claim 37, wherein said placed second metallic structure is radiating/receiving material and said second RF radiating/receiving element is a slot formed from said material, thereby forming a second slot antenna.
- 39. (new) The method of claim 38, wherein said RF functionality activates one or the other of, or both, said first and second slot antennas.
- 40. (new) An RF telemetry unit for use with differing electro-mechanical infrastructures, comprising:
- (a) a first RF radiating/receiving element locatable within one such infrastructure; and
- (b) a first metallic structure placed physically closer to said first RF radiating/receiving element than any such infrastructure is.
- 41. (new) The unit of claim 40, wherein said first metallic structure is RF radiating/receiving material and said first RF radiating/receiving element is a slot formed from said material, thereby forming a first slot antenna.
- 42. (new) The unit of claim 41, further comprising:
- (d) a second RF radiating/receiving element;
- (e) a second metallic structure placed physically closer to said second RF radiating/receiving element than such infrastructure is, wherein, wherein placed second metallic structure is RF radiating/receiving material and said second RF radiating/receiving element is a slot formed from said material, thereby forming a second

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slot antenna.

- 43. (new) The unit of claim 42, wherein said first and second metallic structures are located to effect cooperative RF performance of said first and second antennas.
- 44. (new) The unit of claim 43, wherein the cooperative performance is achieved by locating said first and second antennas so that the dominant null of the radiating/receiving element of one antenna is mitigated by the radiating/receiving element of the other antenna.
- 45. (new) The unit of claim 40, wherein such infrastructure is that of a conventional resource-measuring meter.
- 46. (new) The unit of claim 45, wherein the meter has a cover and said first antenna is located under said cover.
- 47. (new) The unit of claim 40, wherein the first metallic structure includes a supporter therefor, having dielectric properties that do not adversely affect the performance of the radiating/receiving element, and the supporter is shaped to maximize the amount of surface space available for supporting said first metallic structure.